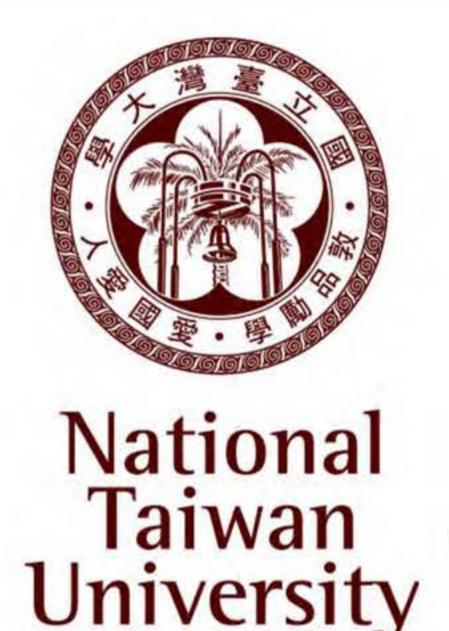


# 2023「中技社科技獎學金

2023 CTCI Foundation Science and Technology Scholarship

### 境外经济统奖等金

Research Scholarship for Overseas Students



## MOCVD Growth of III-Nitride Semiconductor Materials for Optoelectronic Device Applications

國立臺灣大學光電工程學研究所

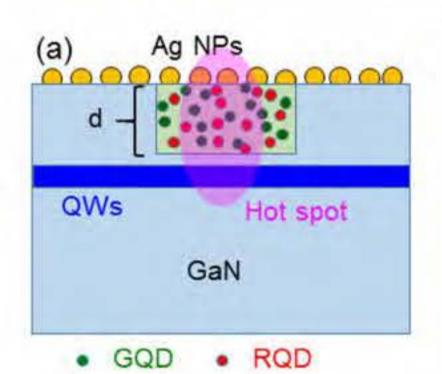
Shaobo Yang, 4<sup>th</sup> Ph.D. candidate, Advisor: Professor Chih-Chung(C. C.) Yang Graduate Institute of Photonics and Optoelectronics, National Taiwan University

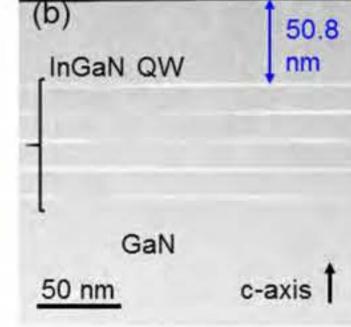
#### **Abstract**

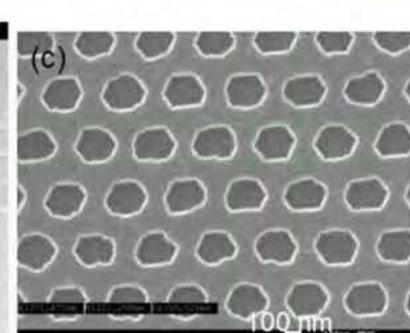
III-Nitride semiconductor materials, including AIN, GaN, and InN, are suitable for electronic and optoelectronic applications due to excellent physical characteristics, such as infrared-to-ultraviolet bandgap and high breakdown voltage. My current research has two aspects: the high-efficiency color conversion for Micro-LED display applications and the strain relaxation effects on overgrowth crystal quality and emission behavior based on the MOCVD-grown samples.

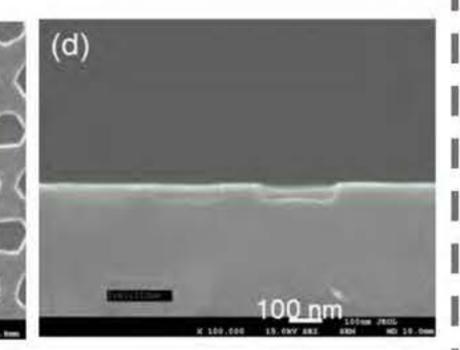
#### Research results

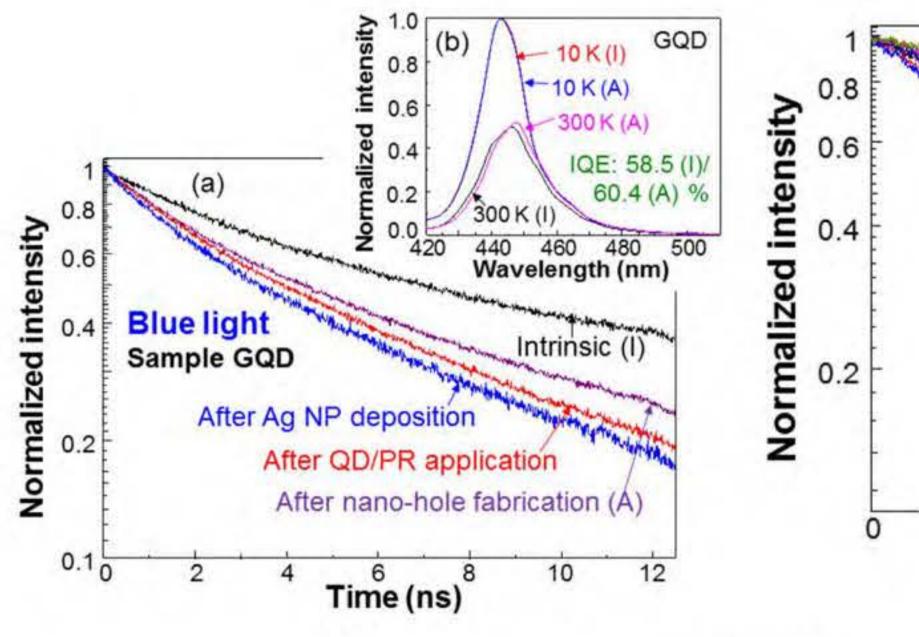
Enhanced Color Conversion of Quantum Dots Located in the Hot Spot of Surface Plasmon Coupling











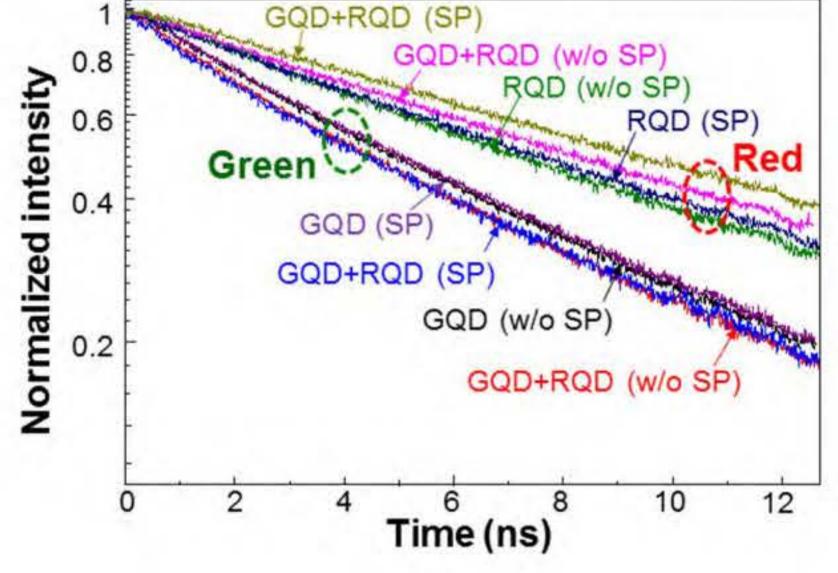


TABLE I

PL DECAY TIMES (IN ns) OF THE BLUE (B), GREEN (G), AND RED (R) LIGHTS IN THE THREE SAMPLES AT DIFFERENT FABRICATION STAGES. THE NUMBERS INSIDE THE CURLY BRACKETS (PARENTHESES) SHOW THE FRET EFFICIENCIES (INTEGRATED INTENSITY RATIOS)

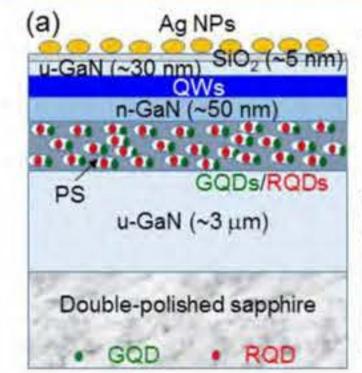
	Intrinsic	After nano-hole fabrication	After QD/PR application	After Ag NP deposition	
В	10.61	7.13	6.46 {9.40 %}	5.81	
G	222		7.08 (0.15)	7.23 (0.24/60 %)	
В	10.11	7.26	6.13 {15.57 %}	5.72	
R			10.11 (0.41)	10.87 (0.77/88 %)	
В	9.91	7.22	6.01 {16.76 %}	5.45	
G	-		6.66 (0.12)	6.77 (0.16/33 %)	
R			11.75 (0.52)	13.07 (0.72/39 %)	
	G B R B	B 10.61 G B 10.11 R B 9.91 G	B 10.61 7.13 G B 10.11 7.26 R B 9.91 7.22 G	B 10.61 7.13 6.46 {9.40 %} G 7.08 (0.15) B 10.11 7.26 6.13 {15.57 %} R 10.11 (0.41) B 9.91 7.22 6.01 {16.76 %} G 6.66 (0.12)	

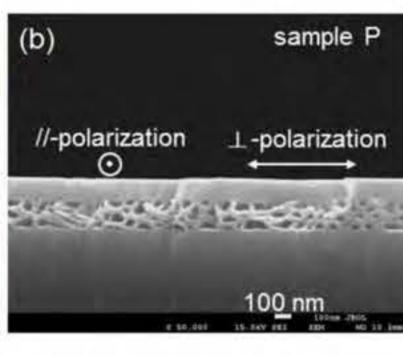
#### Conclusion I

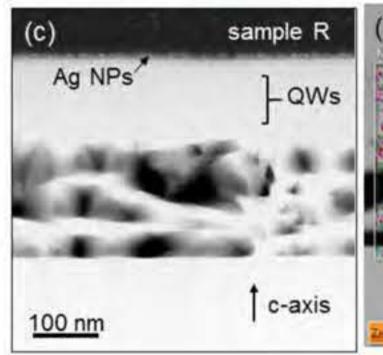
In summary, by inserting QDs into a nano-hole located between a QW structure and surface Ag NPs, we observed the improved performance of the color conversion from QW energy into QD emission.

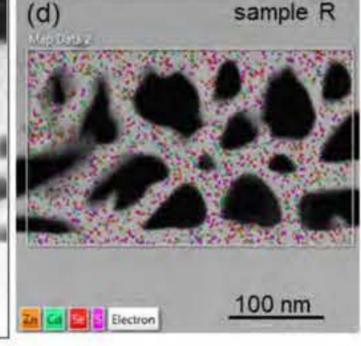
IEEE PHOTONICS TECHNOLOGY LETTERS, VOL. 35, NO. 5, 1 MARCH 2023

Effects of Surface Plasmon Coupling on the Color Conversion of an InGaN/GaN Quantum-Well Structure into Colloidal Quantum Dots Inserted into a Nearby Porous Structure









**Table 1.** Blue-light PL decay times (in ns) in the five samples under study at different fabrication stages. The numbers inside the curly brackets show the corresponding IQEs. The numbers inside the parentheses show the corresponding FRET efficiencies.

Sample	2	A	P	G	R	G+R
Intrinsic		6.48 {57.8%}	6.36 {57.4%}	6.65 {57.9%}	6.67 {56.5%}	6.46 {57.7%}
After PS fabr	ication	_	5.89 {67.2%}	6.04 {68.6%}	5.98 {67.7%}	6.00 {68.1%}
After QD insertion	11	_		5.32 (11.92%)	4.91 (17.89%)	3.75 (37.50%)
	1	<del>,</del> ),	_	5.26 (12.91%)	4.84 (19.06%)	3.74 (37.67%)
After Ag NP deposition	//	5.71 {63.8%}	5.33 {69.4%}	4.85 (19.70%)	4.64 (22.41%)	2.38 (60.33%)
	1		5.23	4.62 (23.51%)	4.49	2.12

**Table 2.** Green- and red-light PL decay times for samples G, R, and G+R in the two polarizations before (w/o SP) and after (SP) Ag NP deposition. The intrinsic PL decay times of GQD and RQD are shown inside the curly brackets in row 1. Also shown in this table are the color ratios, i.e., G/B and R/B ratios, and the polarization ratios (PRs) for the three color components.

Sample	G (//, ⊥) {5.78 ns}		R (//, $\perp$ ) {8.95 ns}		G+R (//, ⊥)	
SP condition	w/o SP	SP	w/o SP	SP	w/o SP	SP
Green decay time (ns)	6.26, 6.22	6.57, 6.48	_	_	3.73, 3.69	3.98, 3.80
Red decay time (ns)	-	<u></u>	9.27, 9.23	9.43, 9.39	11.15, 11.09	11.87, 11.84
G/B ratio	0.107, 0.137	0.172, 0.225	-	<del></del>	0.114, 0.146	0.174 <i>,</i> 0.213
R/B ratio		-	0.365, 0.412	0.371, 0.447	0.530, 0.694	0.696, 0.850
Blue PR	0.948	0.901	0.933	0.897	0.914	0.902
Green PR	1.217	1.179	1	_	1.169	1.103
Red PR	1 <del>5.50</del>	7	1.084	1.090	1.197	1.102

#### Conclusion II

In summary, we have designed and implemented a device structure for improving the color conversion performance from a QW structure into QDs inserted into a nearby subsurface GaN PS by introducing the SP coupling between the QW structure and the LSP resonance on surface Ag NPs to the device.

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